

199584US-38-59-0 CONT



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
OTOJIRA KIDA ET AL : EXAMINER: VERSTEEG
SERIAL NO: 09/729,102 :
FILED: DECEMBER 5, 2000 : GROUP ART UNIT: 1753
FOR: TARGET AND PROCESS FOR ITS
PRODUCTION, AND METHOD
FOR FORMING A FILM HAVING
A HIGH REFRACTIVE INDEX

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6/10/01
7/25/01*

AMENDMENT

RECEIVED
JUN 13 2001
TC 1700

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

In response to the Office Action dated March 13, 2001, please amend the application
identified above as follows (marked-up copy of amendments attached):

IN THE SPECIFICATION

Please amend the specification as follows:

Page 1, replace the first paragraph with

C1
--(New) This application is a Continuation of application Serial No. 09/011,749 filed
on March 12, 1998, which was not published in English, which is now U.S. Patent No.
6,193,856, and which is the National Stage of International Application No. PCT/JP96/00767
filed March 25, 1996.--

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